

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M122-1114		SERIAL NO. 09/233,377	
<div style="position: relative; height: 100px;"> <div style="position: absolute; top: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px; font-size: 24px; font-weight: bold;"> DIPE </div> <div style="position: absolute; top: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px; font-size: 24px; font-weight: bold;"> AUG 27 2001 </div> <div style="position: absolute; top: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px; font-size: 24px; font-weight: bold;"> PATENT & TRADEMARK OFFICE </div> </div>					LIST OF ARTS CITED BY APPLICANT (Attach several sheets if necessary)			
					APPLICANT Micron Technology, Inc.			
					FILING DATE January 18, 1999		GROUP 2813	

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
TSP	AA	6,090,708	7-18-00	Sandhu et al.	438	683	2/1998
	AB						
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FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)		
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EXAMINER	DATE CONSIDERED
	12/17/01

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Form PTO-1449 <div style="border: 2px solid black; border-radius: 50%; padding: 10px; display: inline-block; text-align: center;"> OIPE FEB 19 2002 PATENT & TRADEMARK OFFICE </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MJ22-1114		SERIAL NO. 09/233,377	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology, Inc.		FILING DATE January 18, 1999	
GROUP 2813							

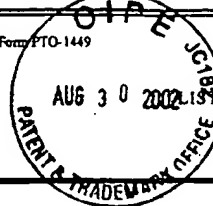
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
TS?	AR		Merriam Webster's Collegiate Dictionary - Ten Edition . ©1996, page 827 (3 pages total).
	AS		
	AT		

EXAMINER	DATE CONSIDERED 5/4/02
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Form PTO-1449 <div style="text-align: center;">  </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1114		SERIAL NO. 09/233,377	
PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology, Inc.		FILING DATE January 18, 1999	
GROUP 2813							

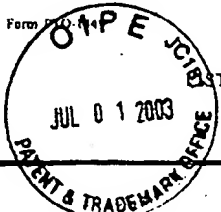
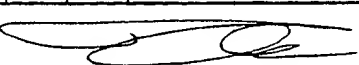
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TSB	AA	6,376,372 B1	04/23/02	Paronje et al.			
	AB	4,897,368	01/30/90	Koboshi et al.			
	AC						
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FOREIGN PATENT DOCUMENTS							
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							Yes No
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	AN						
	AO						
	AP						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
TSB	AR		Omar, M. Ali, "Elementary Solid State Physics," © 1975 by Addison-Wesley Publishing Company, Inc., pages 539-542 (6 pages total).
TSB	AS		Wolf, et al., "Silicon Processing for the VLSI Era - Volume 1-Process Technology," ©1986 by Lattice Press, pages 242, 261, 262, 303, & 304 (7 pages total).
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EXAMINER 	DATE CONSIDERED 4/4/03
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U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TSP	AA	4,378,628	04-1983	Levinstein et al.			
TSP	AB	6,054,387	04-2000	Fukuda			
	AC						
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FOREIGN PATENT DOCUMENTS							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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EXAMINER 				DATE CONSIDERED 12/29/03			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							